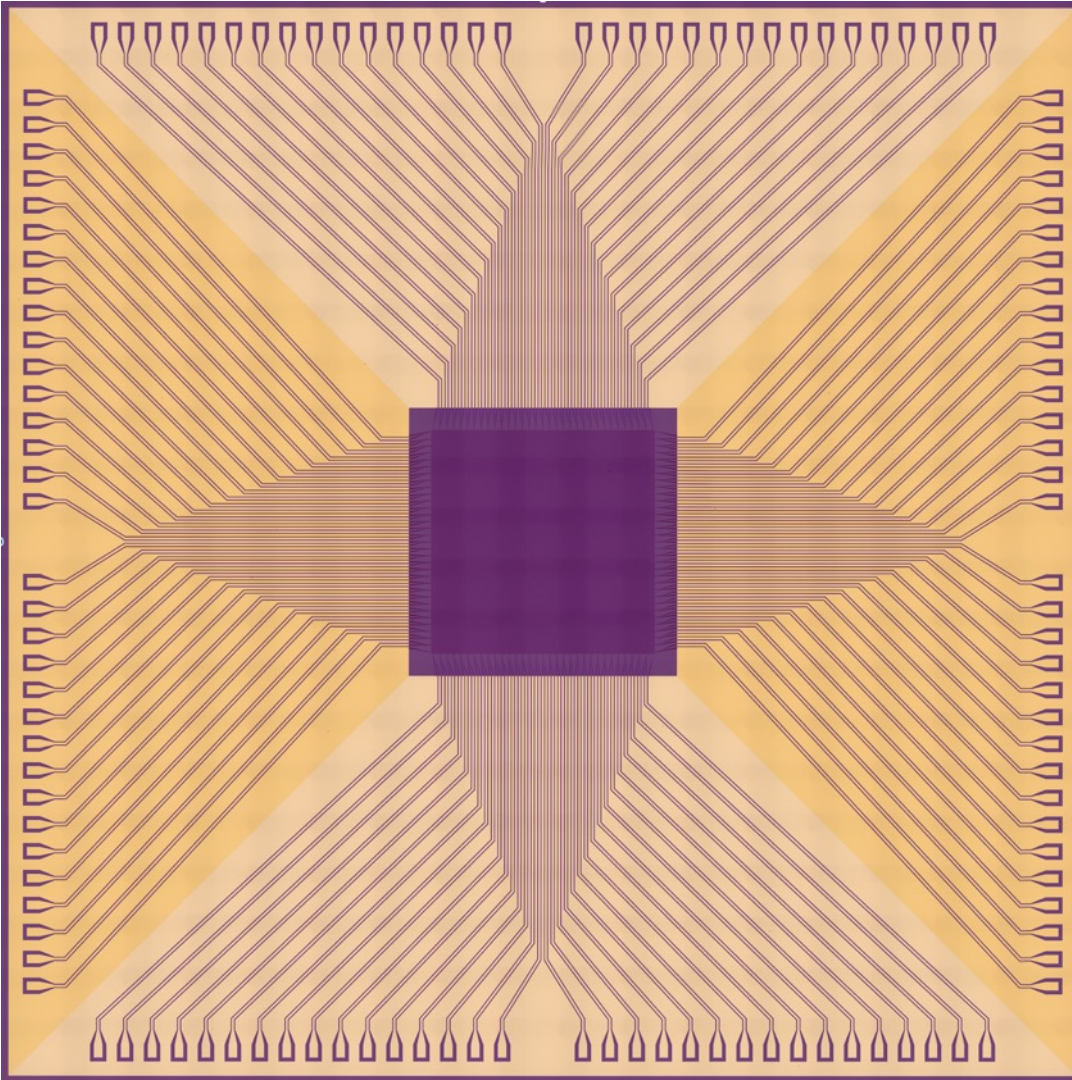


Superconducting Nanowire Single Photon Detectors for Dark Matter Detection and HEP

Matt Shaw
Jet Propulsion Laboratory

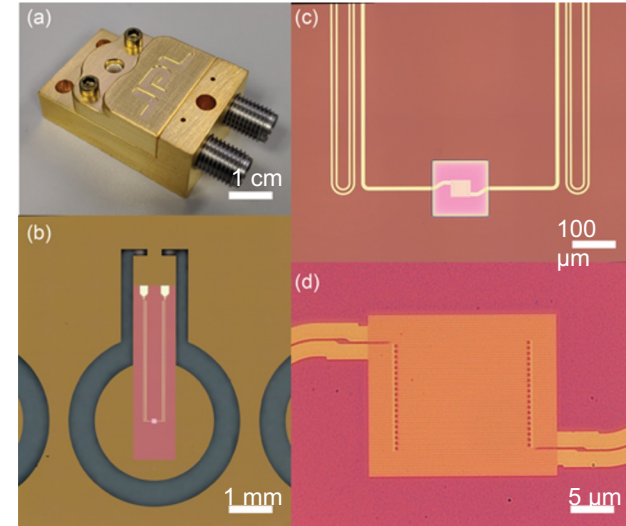
7 November 2023
CPAD Workshop, SLAC



JPL Superconducting and Quantum Devices Group

- **Superconducting Nanowire Single Photon Detectors**
- Microwave Kinetic Inductance Detectors
- Kinetic Inductance Traveling-Wave Parametric Amplifiers
- Quantum Capacitance Detectors
- Transition-Edge Sensors for Cosmic Microwave Background
- Thermopile Arrays for Earth and Planetary Science
- SIS and HEB Mixers for Terahertz Astronomy
- Superconducting Circuits for Quantum Computing

**JPL has been a world leader in
superconducting detector
technology development since 1981**



JPL SNSPD Development Team

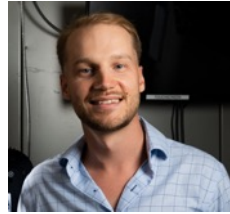
JPL Staff Researchers



Matt Shaw



Emma Wollman



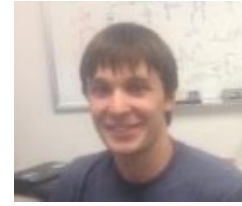
Boris Korzh



Andrew Beyer



Bruce Bumble



Jason Allmaras



Ioana Craiciu

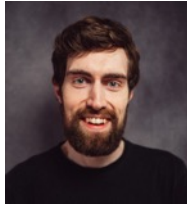


Ryan Briggs

Postdocs



Gregor Taylor



Emanuel Knehr



Dan Shanks



Fiona Fleming
(Heriot-Watt)

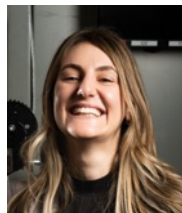
Key Collaborators



Graduate Students



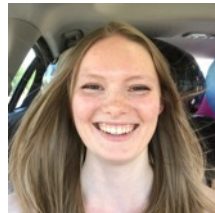
Andrew Mueller
(Caltech APH)



Jamie Luskin
(Maryland)



Sahil Patel
(Caltech MS)



Sasha Sykens
(Arizona State)



JPL SNSPD Development Team

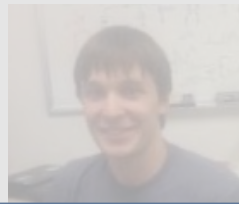
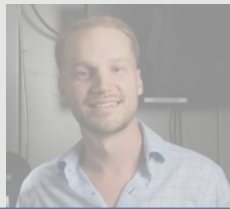
JPL Staff Researchers



Matt Shaw



Emma Wollman

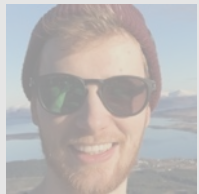


Ioana Craiciu



Ryan Briggs

Postdocs



Gregor Taylor



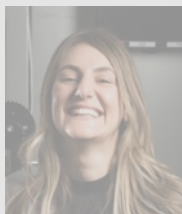
Emanuel Knehr

Join us!
Always recruiting postdocs, students,
nanofabrication engineers
mattshaw@jpl.nasa.gov

Graduate Students



Andrew Mueller
(Caltech APH)



Jamie Luskin
(Maryland)



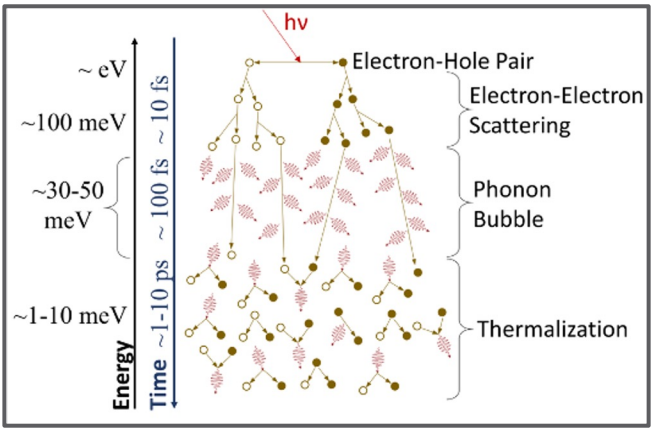
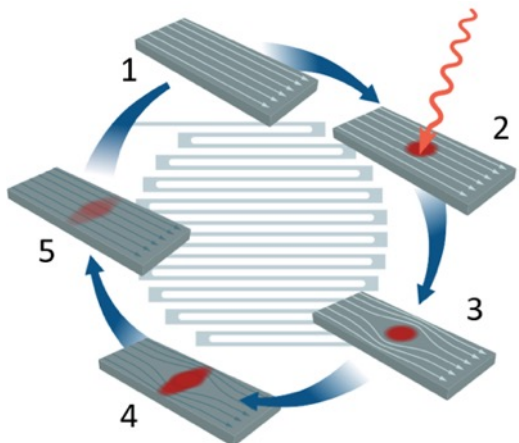
Sahil Patel
(Caltech MS)



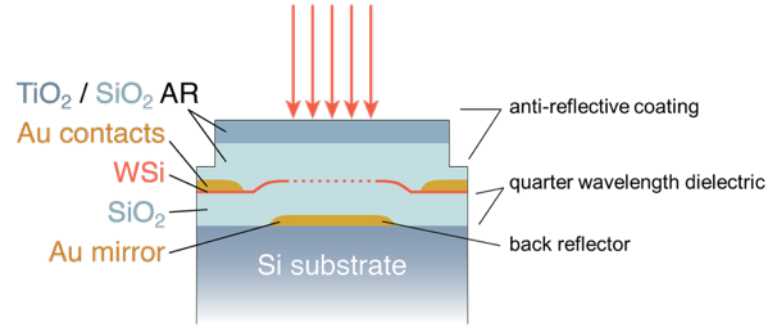
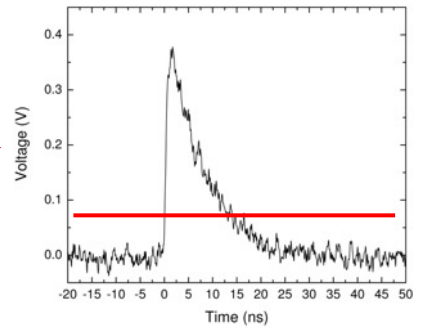
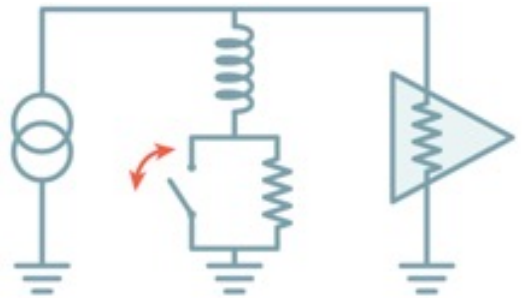
Sasha Sykens
(Arizona State)



Superconducting Nanowire Single Photon Detectors



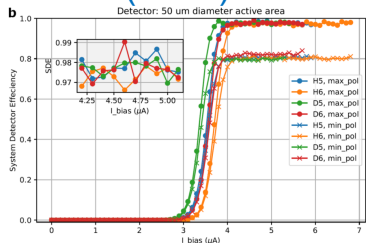
- Time-resolved single photon counting from UV to mid-IR
- Truly digital detection mechanism – reduced drift and zero read noise
- World-leading detector performance
- Operating temperature 1-4 K in most cases



Present State of The Art in SNSPDs

High Efficiency

98% SDE @ 1550 nm (NIST)

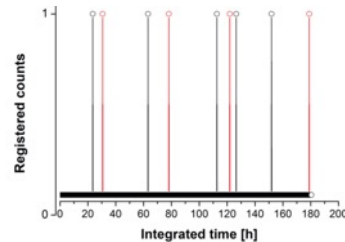
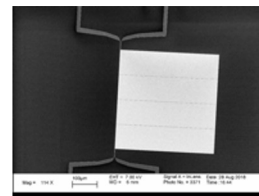


Reddy et al, *Optica* (2020)

Low Dark Counts

6e-6 cps (MIT/NIST)

Chiles et al, *Phys. Rev. Lett.* (2022)

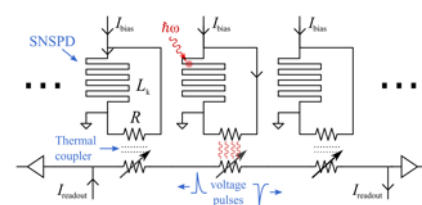
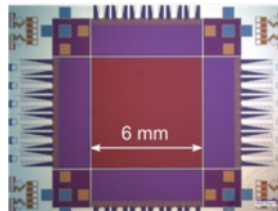
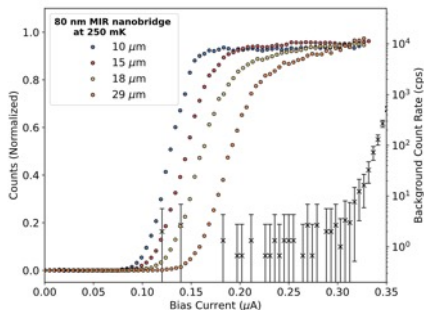
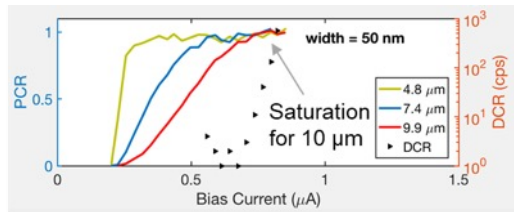


UV – Mid-IR Operation

Photon counting from 0.1 - 29 µm (JPL/MIT/NIST)

Large Array Formats

400 kpix with time-domain multiplexing (NIST/JPL)



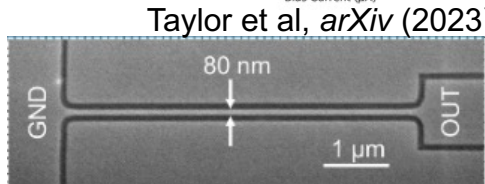
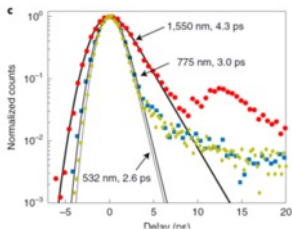
High Time Resolution

2.6 ps FWHM (MIT/JPL/NIST)

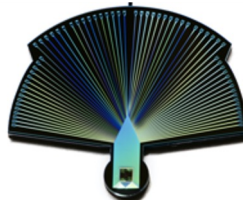
High Event Rate

1.5 Gcps in 32-element array (JPL)

Oripov et al, *Nature* (2023)



Korzh et al, *Nature Photonics* (2020)

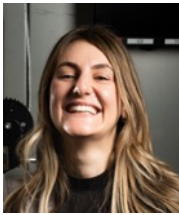


Craiciu et al, *Optica* (2023)

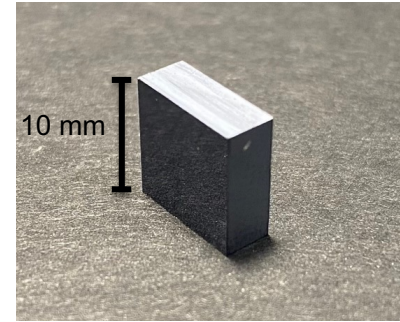
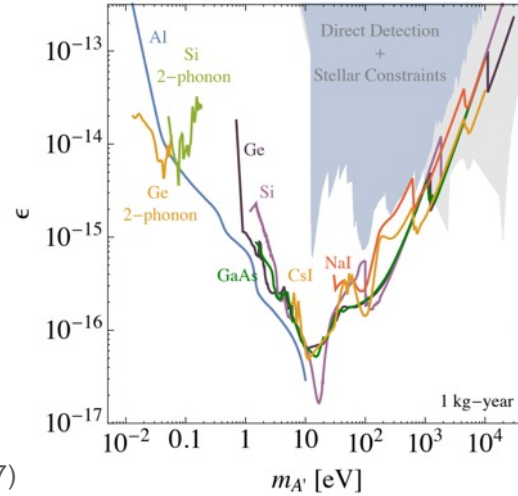
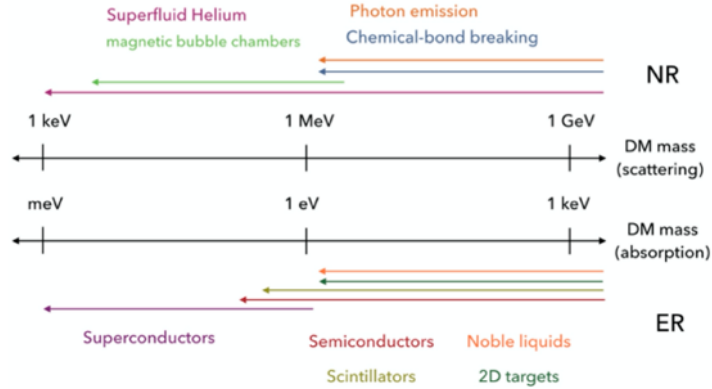


Particle-like DM Search: Electron Recoil in GaAs

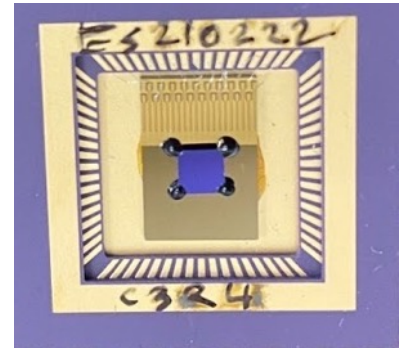
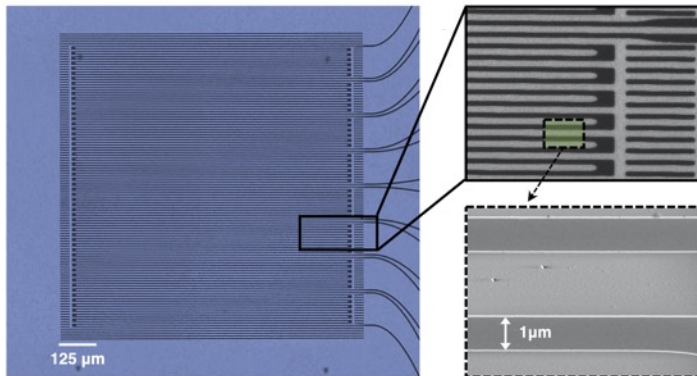
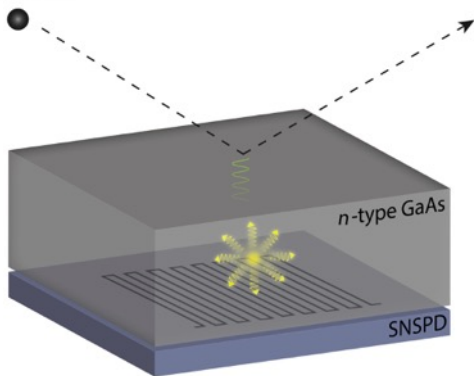
JPL



Jamie Luskin
(Maryland)



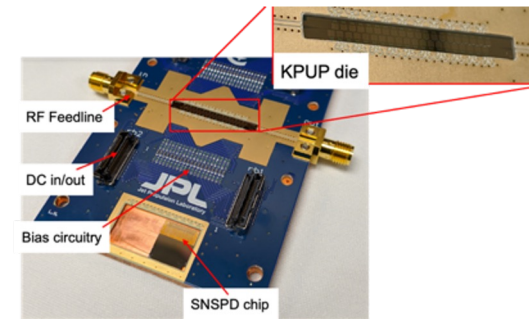
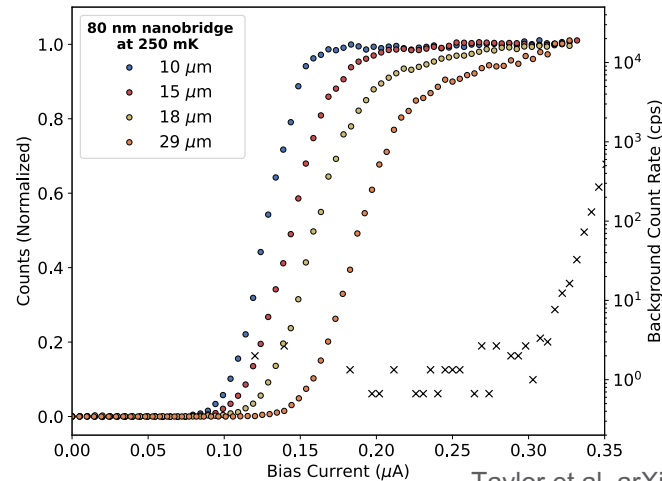
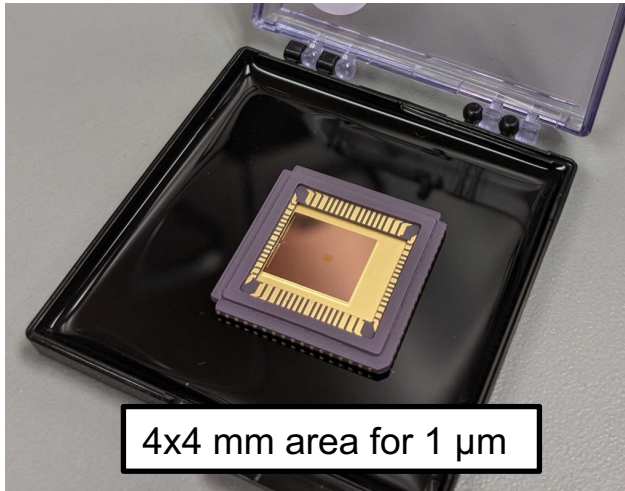
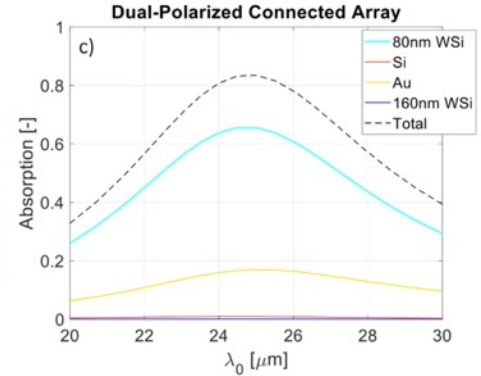
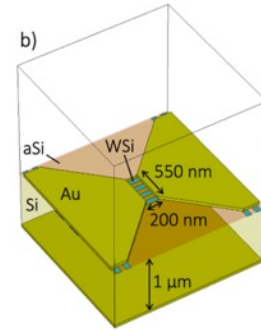
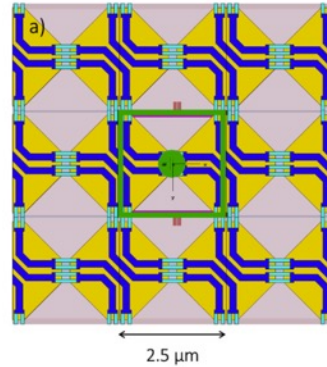
a) Dark Matter (mass ~MeV) US Cosmic Visions Report (2017)



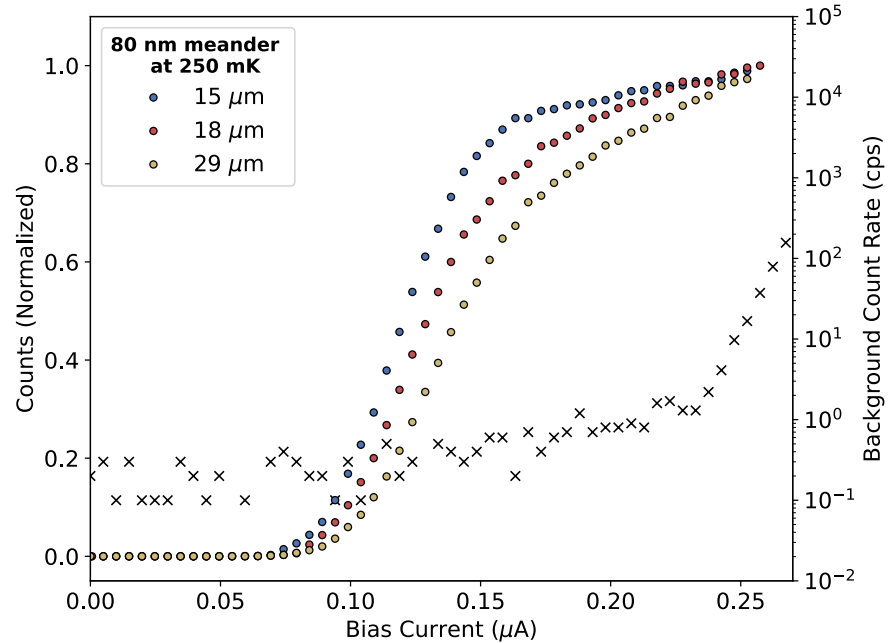
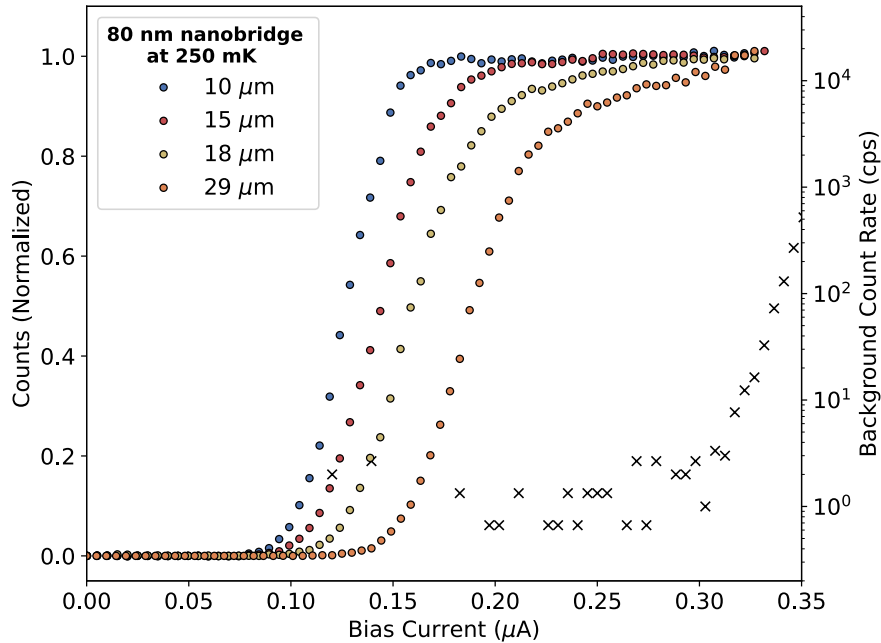
Luskin et al, Applied Phys Lett (2023)

SNSPDs for BREAD

- Delivering large-area SNSPDs for $1\ \mu\text{m}$
- Developing large arrays at longer wavelengths ($10 - 30\ \mu\text{m}$) and pushing energy threshold lower



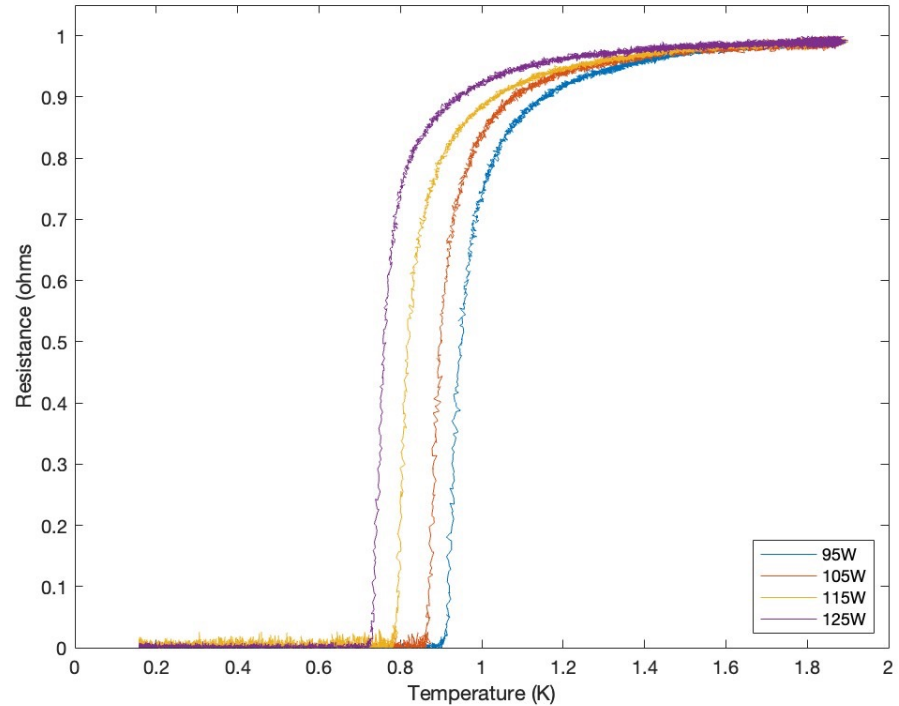
Single Photon Sensitivity up to 29 μm (41 meV)



- SNSPD nanobridge with Si-rich WSi for reduced superconducting gap energy (1.3 K Tc, 80 nm nanobridge)
- Now fabricating WSi devices with an 800 mK Tc for even lower energy threshold

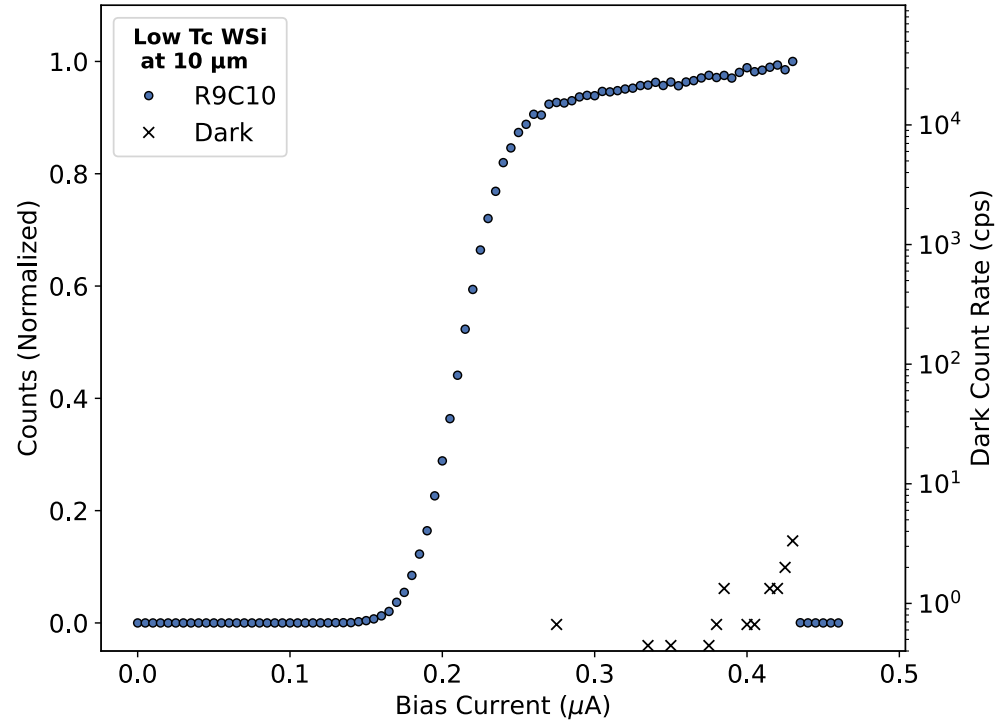
Pushing to Lower Wavelengths

- Co-Sputtering Wsi (30:70) target with Si Target to further increase Si content
- Targeting T_c of 800mK while maintaining a thicker film to make fabrication easier

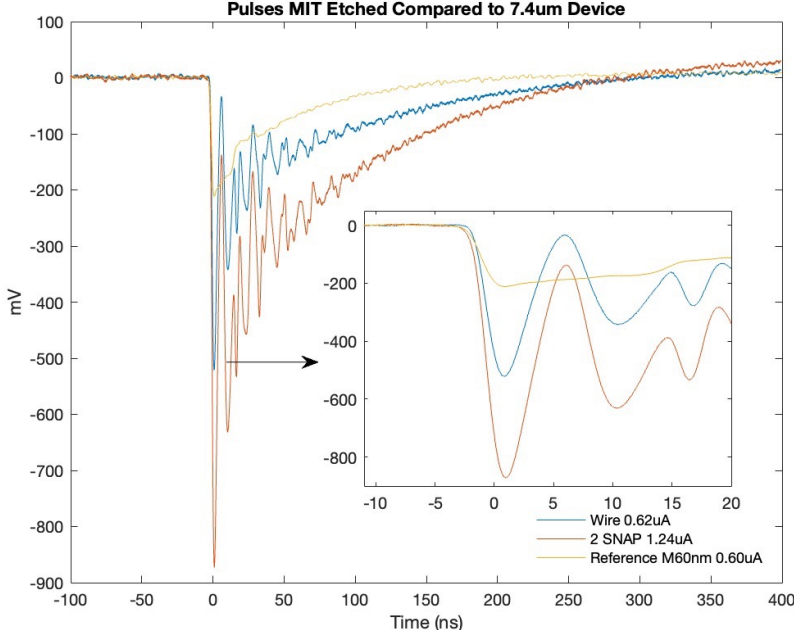
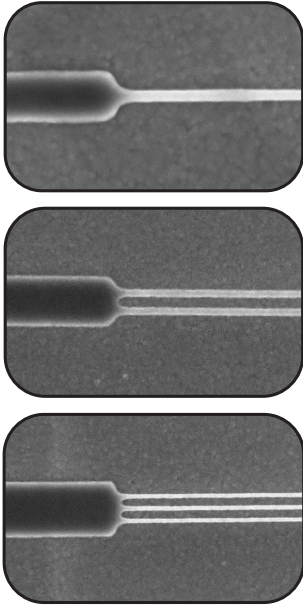
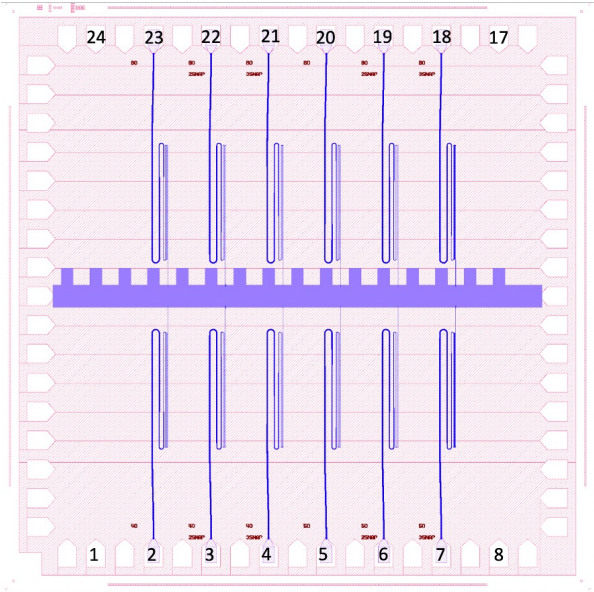


Pushing to Lower Wavelengths

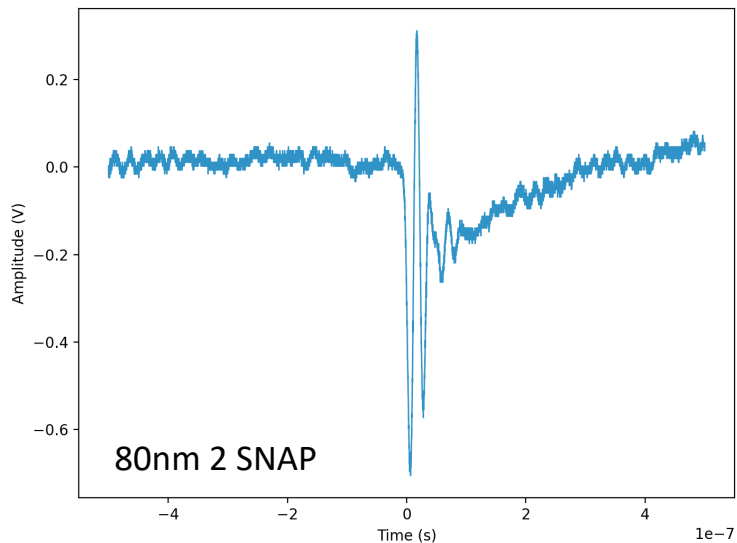
- Co-Sputtering Wsi (30:70) target with Si Target to further increase Si content
- Targeting T_c of 800mK while maintaining a thicker film to make fabrication easier



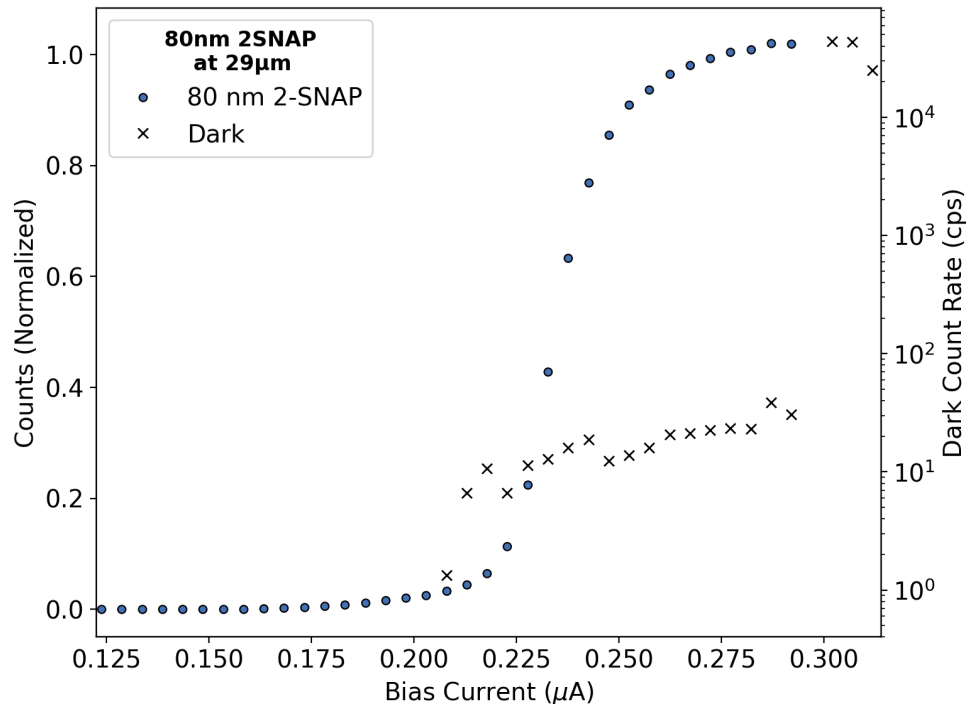
SNAP Devices with Low-Tc WSi



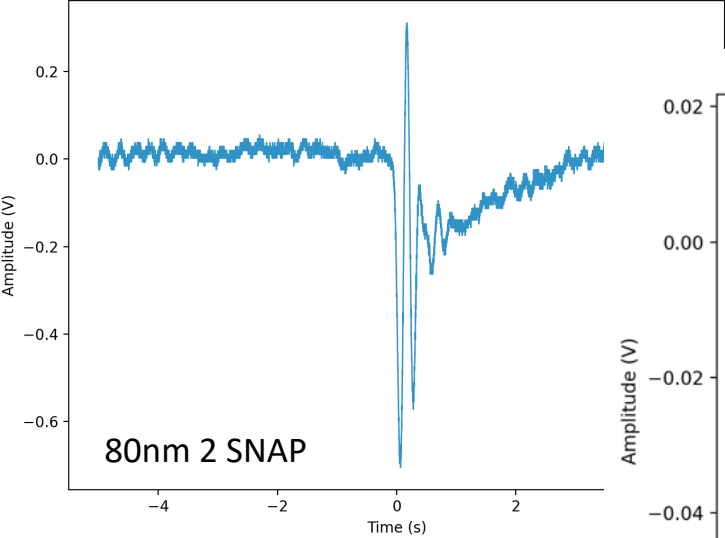
SNAP Devices with Low-Tc WSi



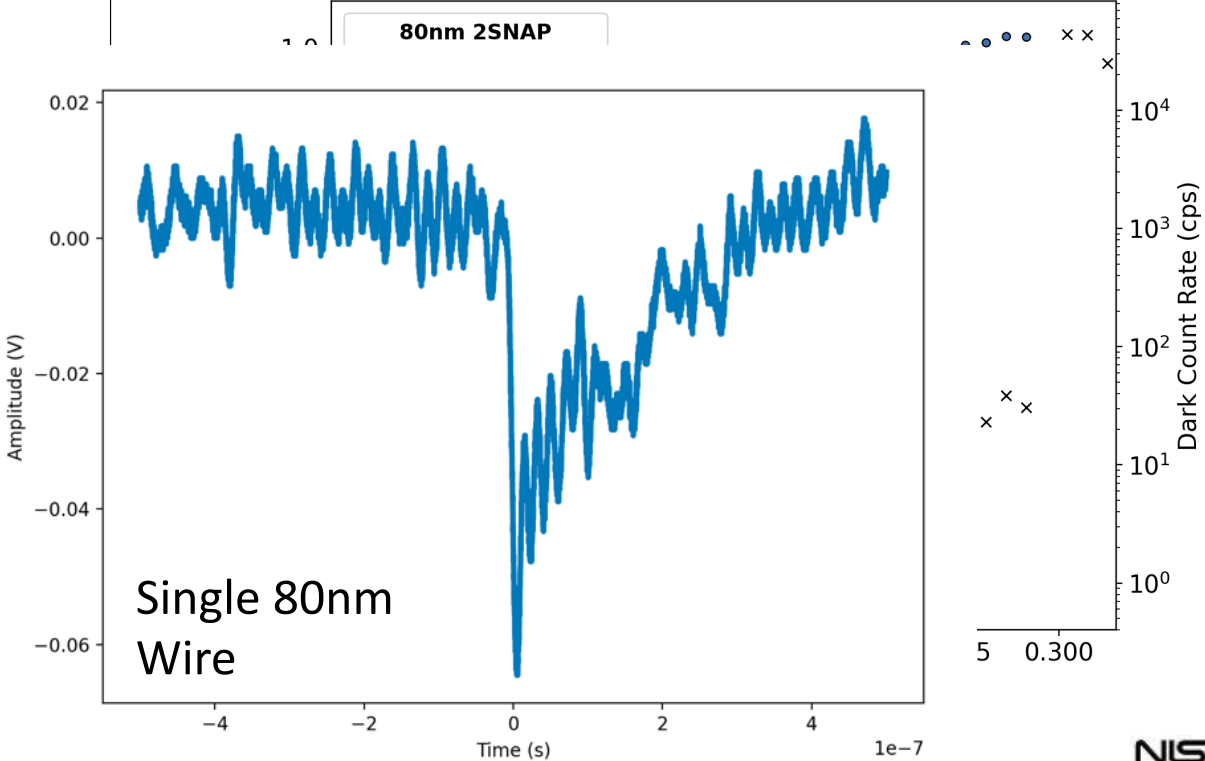
- 80 nm 2 SNAP with impedance matching tapers with 750mK Si Rich film



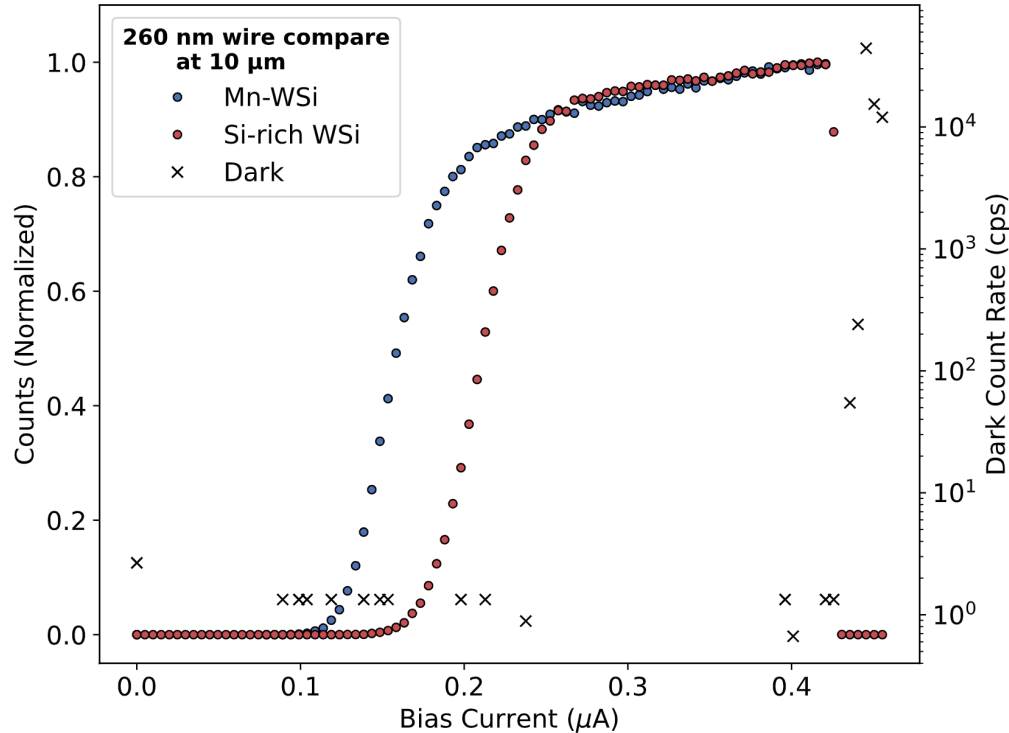
SNAP Devices with Low-Tc WSi



- 80 nm 2 SNAP with impedance match
750mK Si Rich film



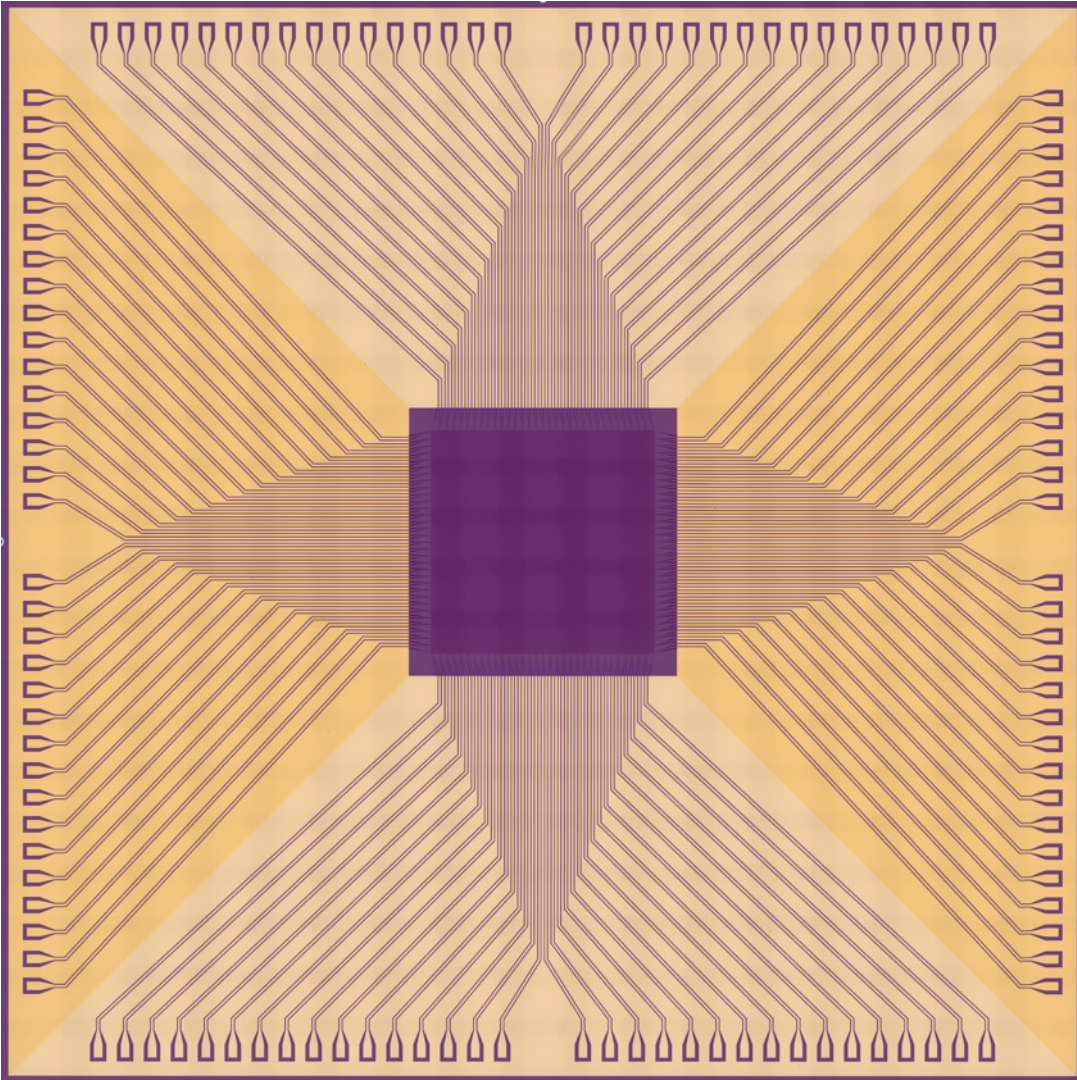
Mn Doped WSi for Longer Wavelengths



- Dilute magnetic impurities create additional disorder in thin films, to enhance energy sensitivity
- Curves above compare devices with same resistivity and critical temperature (800 mK)

Technology Development Path for Low-Threshold SNSPDs

- Materials development to push energy threshold even lower
- Efficient optical coupling at mid- and far-infrared wavelengths with antennas
- Frequency domain multiplexing using kinetic inductance parametric upconverter
- Calibrated efficiency measurements at mid- and far-infrared wavelengths
- Improved understanding and mitigation of low-energy backgrounds
- **Integration into dark matter experiments**



**Thanks for your
attention!**

mattshaw@jpl.nasa.gov

JPL
Jet Propulsion Laboratory
California Institute of Technology